

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Nobuhiro OHKUBO et al.

Serial No.: New Application

Filing Date: February 26, 2004

For: SEMICONDUCTOR LASER DEVICE
AND MANUFACTURING METHOD
THEREOF

Examiner: Not Yet Assigned

Group Art Unit: Not Yet Assigned

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to the calculation of the filing fee, please amend this application as follows:

The listing of claims begins on page 2.

The Remarks begin on page 7.